

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/625,682	CHOI ET AL.	
Examiner	Art Unit	
M. Lee	2622	

SEARCHED				
Class	Subclass	Date	Examiner	
348	730	3/29/2006	ML	
	731	8/28/2006	ML	
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725	131			
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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	DATE	EXMR
EAST	3/29/2006	ML
Updated	8/28/2006	ML